

INTERNATIONAL  
GEMOLOGICAL  
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

October 19, 2024

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG660471510

LABORATORY GROWN DIAMOND

SQUARE EMERALD CUT

8.96 X 8.92 X 5.57 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

4.01 CARATS

E

VS 1

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence


EXCELLENT

EXCELLENT

NONE

Inscription(s)

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

 LG660471510

PROPORTIONS

Medium

68%

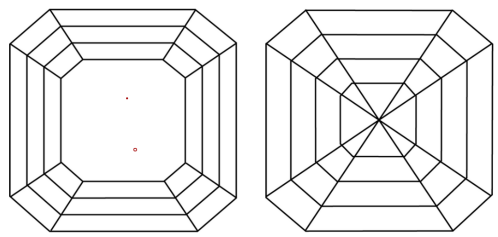
12%

47.5%

62.4%

Pointed

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

IF VS 1-2 VS 1-2 SI 1-2 I 1-3

Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included

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
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